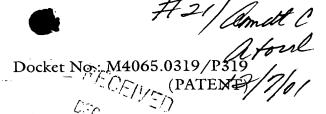
	AMEN	DMENT T	TRANSM	ITTAL L	ETTER	Docket No. M4065.0319/P319
b F 2	Application 09/296,83	-	Filing Date April 22, 1999		Examiner E. Kielin	Group Art Unit 2813
4 27 200n	April 22, 1999 E. Kleim Spplicant(s): Ronald A. Weimer, et al. Invention: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICE INSULATING FILM USING A WET RAPID THERMAL OXIDATION P TO THE COMMISSIONER FOR PATENTS Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					10 P
W7 & TRADEM	Invention: FABRIC INSULA	CATION OF DI ATING FILM U	RAM AND OT SING A WET	HER SEMICO	ONDUCTOR DEVI	CES WITH AN COLOR PROCESS - 3
		TC	THE COMM	ISSIONER FO	OR PATENTS	
	Transmitted here The fee has beer	with is an ame n calculated an	ndment in the d is transmitte	above-identif d as shown b	ied application. elow.	M00,
	CLAIMS AS AMENDED					
		Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
	Total Claims	37	- 37 =		×	0.00
	Independent Claims	5	- 5 =		х	0.00
	Multiple Dependent Claims (check if applicable)					
,	Other fee (please specify): TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00
	x Large Entity Small Entity					
	x No additional fee is required for this amendment.					
	Please charge Deposit Account No in the amount of \$ A duplicate copy of this sheet is enclosed.					
	A check in the amount of \$ to cover the filing fee is enclosed.					
	x The Commissioner is hereby authorized to charge and credit Deposit Account No04-1073 as described below. A duplicate copy of this sheet is enclosed.					
	x Credit any overpayment.					
·	x Charge a	any additional fil	ing or application	on processing	fees required unde	r 37 CFR 1.16 and 1.17.
	Thomas J. D'Amico Attorney Reg. No.: 28,371					November 27, 2001
	DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP 2101 L Street NW Washington, DC 20037-1526 (202) 828-2232					
		-				



HE UNITED STATES PATENT AND TRADEMARK OFFICE OF MAIL OF THE COOPERS OF THE COOPER

In re Patent Application of: Ronald A. Weimer, et al.

Application No.: 09/296,835

Group Art Unit: 2813

Filed: April 22, 1999

Examiner: E. Kielin

For: FABRICATION OF DRAM AND OTHER

SEMICONDUCTOR DEVICES WITH AN

INSULATING FILM USING A WET

RAPID THERMAL OXIDATION PROCESS

AMENDMENT

Box Non-Fee Amendment

Commissioner for Patents Washington, DC 20231

Dear Sir:

In response to the Office Action dated August 28, 2001 (Paper No. 19), please amend the above-identified U.S. Patent application as follows:

In the Claims:

Please amend independent claim 8 and dependent claims 5 and 6 as shown in the Replacement Claims: